

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.                      Docket No. : CIL-10972  
Serial No. : 10/086,614                                      Art Unit : 1762  
Filed : March 1, 2002                                      Examiner : B. Pianalto  
For : Ion-Assisted Deposition Techniques For  
The Planarization Of Topological Defects

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:


This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.

The requested extension fee for a one month extension (37 CFR 1.17(a)(2) is \$420.

The Commissioner is hereby authorized to charge this fee (\$420) to Deposit Account Number 501913.

If any impediments remain, please contact the undersigned at 808-875-0012.

Respectfully submitted,

  
John P. Wooldridge  
Attorney for Applicant  
Registration No. 38,725

Dated: September 30, 2004